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**PATENT AND TRADEMARK OFFICE  
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Sheet 1 of 1

ATTORNEY DOCKET NO.

SERIAL NO.

9319A-000221

09/871,592

APPLICANT

Akira ARAI

FILING DATE

May 30, 2001

GROUP

1742

**U.S. PATENT DOCUMENTS**

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

**FOREIGN PATENT DOCUMENTS**

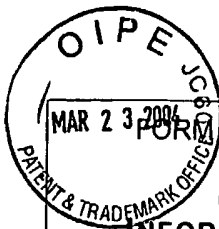
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No
1.	<i>JA</i>	0 936 633	07/23/1998	Europe			

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)**

Ref. Desig.	Examiner's Initials	
1.	<i>JA</i>	Search Report from corres. European Patent Office Patent Application No. 01112805.5.

**RECEIVED**  
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**TC 1700**Examiner: *John O. [Signature]*Date Considered: *2/12/04*

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1.	<i>JA</i>	11-277188	10/12/1999	Japan	<u>        </u>	X	
2.							

**OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)**

Ref. Desig.	Examiner's Initials	
1.		<del>Communication from Chinese Patent Office re: counterpart application.</del>

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Examiner:

*John P. Lee*

Date Considered:

*10/22/04*

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